

Docket No. SH-0069PCTUS  
RYU.034  
Serial No. 10/594,529



ITW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of

Tetsuya OTOSAKA

Serial No.: 10/594,529

Group Art Unit: 1791

Filing Date: September 28, 2006

Examiner: Unknown

For: MANUFACTURING APPARATUS OF POROUS GLASS BASE  
MATERIAL

Honorable Commissioner of Patents  
Alexandria, Virginia 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to Applicant's duty of disclosure under 37 CFR §1.56, Applicant respectfully brings the following document cited in the Chinese Office Action in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. A copy of the listed Patent Application Publication is not provided in compliance with *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, 1273 Off. Gaz. Pat. Office 55 (August 5, 2003). For the convenience of the Examiner, a copy of the first page of the listed Patent Application Publication is provided.

In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, Applicant encloses herewith a copy of the Chinese Search Report citing such documents, together with an English-language version (if not already included) of that portion of the Search Report indicating the degree of relevance found by the

Docket No. SH-0069PCTUS  
RYU.034

foreign office. Further, an English-language Abstract is attached to the reference and the U.S. equivalent U.S. Patent Application Publication US 2003/0015004 is attached.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which Applicant is aware.

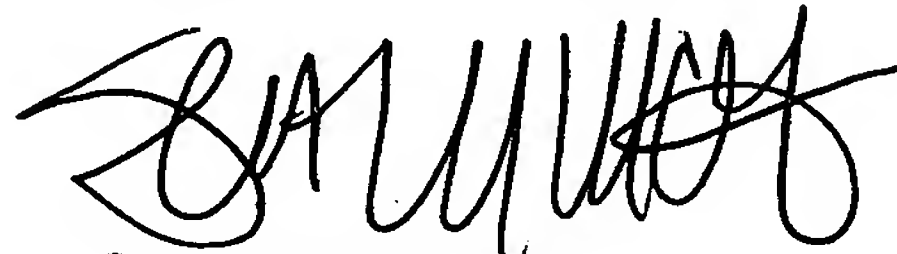
I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is noted that U.S. Patent Application Publication No. US 2003/0015004 is the U.S. equivalent of Chinese Unexamined Patent Application No. CN1397507.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



Sean M. McGinn, Esq.  
Registration No. 34,386

Date: 6/18/09  
**MCGINN INTELLECTUAL PROPERTY**  
**LAW GROUP, PLLC**  
8321 Old Courthouse Road, Suite 200  
Vienna, Virginia 22182-3817  
(703) 761-4100  
Customer No. 21254